



21w

500.41316VX1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): T. KAJI, et al
Serial No.: ~~40/090,759~~ 10/659,394
Filed: September 11, 2003
For: EMISSION SPECTROSCOPIC PROCESSING APPARATUS
AND PLASMA PROCESSING METHOD USING IT
Group: 1763
Examiner: P. Hassanzadeh

AMENDMENT

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

September 8, 2004

Sir:

In response to the Office Action dated June 8, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application, as listed below and as set forth on the following pages:

Amendment of the Specification;
Amendment of the Claims; and
Remarks are included following the amendments.